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PATENT

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Sir:

Transmitted herewith for filing is the patent application of:

Inventor(s): Karl-Heinz SCHUSTER, Harry BAUER

For: **DEVICE FOR REDUCING THE PEAK POWER
OF A PULSED LASER LIGHT SOURCE**

Enclosed are:

(X) 12 pages of specification, including 13 claims and an abstract.

(X) an executed oath or declaration, with power of attorney.

() an unexecuted oath or declaration, with power of attorney.

() sheet(s) of informal drawing(s).(X) 3 sheet(s) of formal drawing(s).(X) Assignment(s) of the invention to Carl-Zeiss-Stiftung

(X) Assignment Form Cover Sheet.

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Fee Calculation For Claims As Filed

- | | | | | | | |
|------------------------------|---------------|---|---------------|---|--------------|-----------------------------------|
| a) Basic Fee | | | | | | \$ 690.00 |
| b) Independent Claims | <u> 1 </u> | - | <u> 3 </u> | = | <u> 0 </u> | x \$ 78.00 = \$ <u> </u> |
| c) Total Claims | <u> 13 </u> | - | <u> 20 </u> | = | <u> 0 </u> | x \$ 18.00 = \$ <u> </u> |
| d) Multiple Dependent Claims | | | | | | \$260.00 = \$ <u> </u> |
- () Statement(s) of Status as Small Entity, reducing Filing Fee by half to \$
- (X) A check in the amount of \$730.00 to cover the filing and assignment recordal fee is enclosed.
- () Charge \$ to Deposit Account No. 23-0920.
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1328896
U.S. PTO

120 South Riverside Plaza
22nd Floor
Chicago, Illinois 60606-3903
Telephone: (312) 655-1500

WELSH & KATZ, LTD.

By Gerald T. Shekleton
Gerald T. Shekleton
Registration No. 27,466

Description:

5 Device for reducing the peak power of a pulsed laser light source

The invention relates to a device for reducing the peak power of a pulsed laser light source, in particular for a projection exposure system.

10 Pulsed laser light sources, for example excimer lasers, for UV lithography have a repetition rate of approximately 1000 to 4000 pulses per second. The pulse length is currently 20 to 30 ns. Depending on the gas state, or the state of the laser, in particular of the optical components, and depending on the resonator length, substantial modulations of the laser output power occur over time within every pulse.

15 It has emerged in practice in this case that a clear disadvantage of a pulsed laser light source consists in that the short pulse duration causes a high pulse power density which has a very negative effect on the optical materials, in particular vitreous materials. In the case of an operating wavelength of 193 nm, quartz glass is damaged at a rate containing one power of the power density. The consequences of this are transmission losses and an uncontrolled increase in the refractive index, which limits the service life of the optical system. There are points with particularly weak bonds in the case of SiO₂ in vitreous form. The pulsed shortwave electromagnetic beams generated by the pulsed laser light source therefore supply the energy in order to modify these points disadvantageously.

20 EP 0 785 473 A2 discloses a device of the type mentioned at the beginning by means of which the light coming from a pulsed laser light source is spread into a plurality of partial beams which traverse detour lines. This produces a beam expansion or a splitting into a plurality of partial beams arranged next to one

another. These partial beams are input into an illuminating apparatus in a fashion arranged next to one another.

5 However, it is a disadvantage in this case that a plurality of optical axes are thereby produced next to one another, and the illuminating apparatus has to be correspondingly adapted. Moreover, the aforementioned device is of fixed alignment.

10 US 5,661,748 describes a pulse-retarding apparatus with semitransparent mirrors and a positive "tail" of the pulse distribution, and an arrangement with two concave mirrors and a dissected mirror in which an offset (part 4.2) occurs in principle which is not produced by the oblique passage through plane
15 plates.

20 It is therefore the object of the present invention to create a device with the aid of which damage is avoided to components which are situated in the beam path of the pulsed laser light source, specifically as far as possible without particular losses in the efficiency of the pulse laser light source.

25 This object is achieved according to the invention by means of the measures named in the characterizing part of claim 1.

30 According to the invention, the high peaks of the pulsed laser light source are now lowered and the pulse power density is reduced, specifically in conjunction with only low integral energy losses. The beam splitting in conjunction with the detour line splits the beam of the pulsed laser light source into partial beams having an optical path difference. In this case, it need only be ensured that the optical path difference is selected such that peaks and valleys
35 at least largely complement one another. Peaks and valleys are spaced apart in time, for example 7.0 ns. This corresponds to a light path of 2.1 m. In order to halve the pulse power density of whole pulses, they are split into a plurality of pulses and then lined up in

terms of time. In order to produce as large as possible a reduction in the peaks inside a pulse and a largely uniform power density, it is proposed in an advantageous refinement of the invention to arrange at least two detour lines in series in the beam path.

According to the invention, it is not the case that a plurality of partial beams are produced which are arranged juxtaposed with a corresponding number of optical axes; rather, the partial beams are reunited to form a total beam, the result being to provide a unified optical axis for the downstream illuminating apparatus. Finally, rethreading takes place after the division into a plurality of partial beams.

In a particularly advantageous way, the device according to the invention can be used to influence polarized light, for which purpose an angle, preferably the Brewster angle, is correspondingly provided between the beam path and the beam splitter apparatus. As a result of the Brewster angle, 50% (apart from absorption in the splitter layer) of the beam passes unhindered and without loss through the beam splitter apparatus, for example a mirror, while the other 50% is dissipated. Of course, however, yet other angles and thereby also yet other percentage splits are possible within the scope of the invention.

In a further refinement of the invention, it can be provided that the beam recombining element is constructed such that a portion of the partial beam which has run via the detour line is repeatedly sent via the detour line.

It is possible in this way to achieve yet more optical path differences, and thus an even stronger degree of uniformity. Additional losses from the mirror and splitter also come to bear, of course.

A phase-retarding plate in the beam path influences the power peaks and the service life of the optical materials which are exposed to the pulsed laser light source.

Further advantageous refinements and developments follow from the remaining subclaims and from the exemplary embodiment described below in principle with the aid of the drawing, in which:

- 5 Figure 1 shows an illustration of the principle of the beam path of a pulsed laser light source having two detour lines;
- Figure 2 shows the power of the pulsed laser light source in the state split by a first detour line;
- 10 Figure 3 shows the power characteristic of the pulsed laser light source in accordance with a second detour line;
- Figure 4 shows a schematic illustration of a further embodiment of the device according to the invention; and
- 15 Figure 5 shows an illustration of the principle of a projection exposure system having an excimer laser and the device according to the invention.
- 20

In accordance with the illustration in Figure 1, a beam 1 from a pulsed laser light source, for example an excimer laser 2 (illustrated in Figure 5) strikes a first beam splitter apparatus in the form of a mirror 3. 50% of the total beam passes the splitter mirror 3 as partial beam 1a without hindrance or loss in the direction of a second splitter mirror 4 as second beam splitter apparatus. The other 50% of the beam passes as partial beam 1b via a detour line 5, which is formed by three mirrors 6, 7 and 8 as reflecting members. The splitter mirror 3 as first beam splitter apparatus also acts, on its rear side, simultaneously as beam recombining element 9 in which the partial beam 1b is reunited with the partial beam 1a passing through the beam splitter apparatus. The pulse of the pulsed laser light source 2 is inherently smoothed by the first detour line 5. At the same time, in this case the peak power is reduced by 30 to 40%. Because of the angular position of the splitter mirror

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3 and the first detour line 5 relative to the direction of oscillation of the incident linearly polarized laser light, the level of the degree of polarization plays no role in the energy balance. Both partial beams 1a and 1b are equally polarized at the output of the first detour line 5, but are offset in time.

The temporal offset of the two partial beams 1a and 1b can be seen from Figure 2. As may be seen, because of the temporal offset of the two peaks P_1 and P_2 , in the event of addition the peak power of the pulsed laser light source, which has been reduced to half in each case because of the beam splitting, is reduced correspondingly in the total peak resulting therefrom by comparison with an untreated beam path.

After the reuniting of the two partial beams 1a and 1b in the further beam path by the second beam splitter apparatus in the form of the splitter mirror 4, which is, in turn, situated rotated by 45° (Brewster angle) relative to the direction of oscillation of the laser light, the laser light beam is split into the partial beam 10a, which passes the splitter mirror 4 without hindrance, and the partial beam 10b, which is sent via a second detour line 11. The second detour line 11 is likewise formed by mirrors 12, 13 and 14 as reflecting members. The rear side of the beam splitter 4 serves, in turn, as second beam recombining element 15, through which the two partial beams 10a and 10b are recombined in conjunction with the same direction of polarization and subsequently passed on jointly.

The pulse of the pulsed laser light source 2 is offset as a whole by the second detour line 11, which can have a path of 11.1 m, for example. This produces at the output or at the beam recombining element 15 two pulses of the same polarization which are largely smoothed or no longer have impermissibly high peaks which could lead to damage to members.

Figure 3 shows the power against time and the two pulses such as are present downstream of the beam recombining element 15. The original power peaks can be

reduced in this case to approximately a third of the original value. If, for example, the time duration of the pulse of the pulsed laser light source is 30 ns, this corresponds to a light path of 9 m. If, in accordance with the exemplary embodiment, the first detour line 5 is combined with the second detour line 11, there is once a delay of 2.1 m and the pulse smoothed in this way is delayed $9.0 \text{ m} + 2.1 \text{ m}$, that is to say a total of 11.1 m, in the second detour line 11.

Regions between the laser output and a scanner input are best suited for the measures according to the invention.

The particular advantage of the invention resides in the fact that the downstream illuminating unit need not be specially designed, but that the proposed apparatus can be inserted only between the laser output and the input of the illuminating part of a scanner. This also makes it possible economically to retrofit existing systems (no new illuminating part of the scanner).

If the beam quality of the pulsed laser light source is degraded by the different path lengths, it can be reconstituted, for example, by means of a Kepler telescope (somewhat adapted to the excimer laser divergence in the individual case) with its two lenses 16a and 16b - as indicated in Figure 1 - in the second detour line 11. A single lens also comes into consideration for this purpose. However, it is also possible, of course, to extend the design mentioned above and, for example, to provide yet further detour lines to the extent that appears spatially feasible and that a further lowering of the peak powers still yields advantages.

It is also likewise conceivable to split the beam physically instead of in terms of polarization optics. When the peak power of a pulsed laser light source is reduced by half, for example by offsetting the partial beams appropriately in time, the risk of damage to members is reduced not only by half, but even

by yet more. Since the peaks in the individual pulse are structured, this being a result of the resonator length in the laser, it is possible to achieve even with short delay paths that the pulse is offset within its length and the structuring is utilized appropriately, as a result of which it is possible to achieve a distinct flattening. Because of the structure of the pulses of pulsed laser light sources, it is possible in this case to reduce the power peaks clearly by even small detour lines. Of course, an optimum is achieved whenever the temporal shift due to the beam splitting is so large that peaks and valleys can respectively be assigned. This can be achieved, for example, by means of the second detour line 11. Instead of the mirrors as reflecting members, it is also possible to provide other reflecting members, such as prisms, for example.

If a $\lambda/4$ plate (not illustrated) is used to produce circularly polarized light upstream of the device, every azimuthal angle about the Z axis is possible for the beam splitter apparatus 3 and 4.

A further embodiment of the device according to the invention is illustrated in principle in Figure 4. As may be seen, the beam 1 is split at the beam splitter apparatus 3 into a partial beam 1a, which goes through the beam splitter apparatus 3 and a partial beam 1b, which takes the path via the rectangular detour line 5. The detour line 5 is formed in this case by four mirrors 17, 18, 19 and 20 before the partial beam 1b on the rear side of the beam splitter apparatus 3, which serves as beam recombining element 9 just as in the case of the exemplary embodiment according to Figure 1, is reunited with the partial beam 1a.

By contrast with the exemplary embodiment according to Figure 1, however, in this case there is no complete union; instead, the embodiment according to Figure 4 is configured such that a portion of the partial beam 1b running over the detour line 5 once again takes the path via the detour path 5, it being

possible for this to be carried out several times. The coupling of the beam takes place in this exemplary embodiment in the manner of a resonator, the portion of the light or partial beam 1b circulating via the detour line 5, that is to say the adjustable pulse length, being a function of the state of polarization. It is possible in this way to achieve arbitrary delays of the incoming pulses and, associated therewith, a lowering of the pulse peak energy of the pulsed laser light source. All that must be ensured in this case is that an optimum is chosen between a temporal lengthening of the partial pulses (number of the resonator circulations) and the total losses. This is achieved by the arrangement of a phase-retarding plate 21 in the beam path upstream of the beam splitter apparatus 3 and a further phase-retarding plate 22 in the detour line 1b. In this way, linearly polarized light is converted into slightly elliptically polarized light which upon traversing the beam splitter apparatus 3 is reflected out with an appropriate component. The height of the component depends in this case on the degree of the ellipse. If, for example, the phase-retarding plate 21 is equipped with a $\lambda/4$ value, an absolute value at the level of 50% is sent via the detour line 1b. In practice, λ values of between 0 and a quarter will be selected.

The configuration according to Figure 4 with the two phase-retarding plates 21 and 22 has the advantage that the device can be adjusted very variably in this way. Specifically, if one or both phase-retarding plates 21 and/or 22 are exchanged, there is a corresponding change in the peak power. If, for example, it were desired to achieve a higher power, something which necessarily produces a higher loading and thus a shorter service life for the device, use is made of phase-retarding plates 21 and/or 22 which entail correspondingly fewer circulations. Conversely, it is possible in this way also to be kinder to the optical members of the projection exposure system by an

appropriate increase in the number of circulations of the light.

Figure 5 illustrates in principle a site of use of the device 22 according to the invention. The polarized light source 2 is accordingly provided, for example, for a projection exposure system which is located in a clean room separated from the surroundings by a wall 17 and having an illuminating optical system 18, a mask 19, a projection lens 20 and a laser 21. In order to be able to influence the clean room as little as possible, in this case the device 22, which is provided in the interior with the parts illustrated in Figure 1, can be arranged between the pulsed laser light source 2 and the wall 17 in the beam path 1 of the pulsed laser light source 2.

Patent Claims:

1. A device for reducing the peak power of a pulsed laser light source, in particular for a projection exposure system, there being arranged in the beam path of the pulsed laser light source at least one beam splitter apparatus by means of which at least one detour line for at least one partial beam is produced via reflecting components, wherein there is arranged in the beam path (1) a beam recombining element (9) in or on which the partial beams (1a, 10a, 1b, 10b) are reunited to form a total beam.
2. The device as claimed in claim 1, wherein the detour line (5 or 11) has a length such that an optical path difference of more than 0.5 m is produced between the partial beams (1a, 1b or 10a, 10b).
3. The device as claimed in claim 1, wherein at least three reflecting components (6, 7, 8 or 12, 13, 14) form a detour line (5 or 11).
4. The device as claimed in claim 1, wherein for polarized laser beams the beam splitter apparatus has a mirror (3 or 4) which is arranged at an angle to the beam path (1).
5. The device as claimed in claim 4, wherein the angle is between 35 and 50°.
6. The device as claimed in claim 5, wherein the Brewster angle is provided as the angle.
7. The device as claimed in claim 1, wherein the reflecting components are constructed as mirrors (6, 7, 8 or 12, 13, 14).
8. The device as claimed in claim 1, wherein two detour lines (5, 11) are arranged in series in the beam path (1).
9. The device as claimed in claim 8, wherein a first detour line (5) has a length of over 2 m, and a second detour line (11) has a length of over 10 m.
10. The device as claimed in claim 1, wherein an easily detuned Kepler telescope (16a, 16b) is arranged in the detour line or lines (5, 11).

11. The device as claimed in claim 1, wherein the beam recombining element (9, 15) is constructed such that a portion of the partial beam (1b or 10b) which has run via the detour line (5 or 11) is repeatedly sent via the detour line (5 or 11).

12. The device as claimed in claim 11, wherein at least one phase-retarding plate (21, 22) is arranged in the beam path.

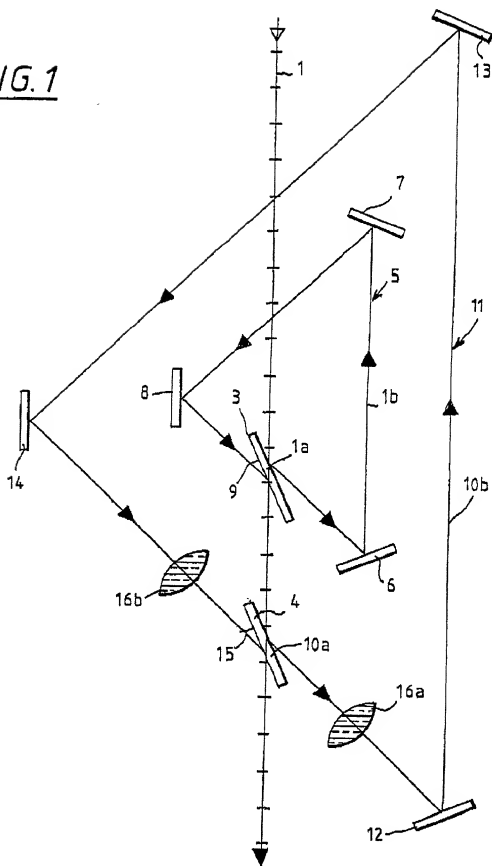
13. The device as claimed in claim 12, wherein a
10 phase-retarding plate (21) is arranged in the beam path
(1) upstream of the beam splitter apparatus (3), and at
least one further phase-retarding plate (22) is
arranged in the detour line (5).

Figure 1 consists of 12 diagrams arranged in two rows of six. The top row shows the initial state (a) and the first four stages of evolution (b, c, d, e, f). The bottom row shows the final stage (g) and the last four stages (h, i, j, k, l). The diagrams illustrate the formation and growth of a vortex pair, with the vortices moving apart and the surrounding fluid being entrained. The diagrams are labeled with letters a through l.

(Figure 1)

In a device for reducing the peak power of a pulsed laser light source, in particular for a projection exposure system, there is arranged in the beam path (1) at least one beam splitter apparatus (3, 4) by means of which a detour line (5 or 11) is produced, via reflecting components (6, 7, 8 or 12, 13, 14) for at least one partial beam (1b) with subsequent recombination at a beam recombining element (9 or 15) with the other partial beam or beams (1b or 10b) to form a total beam.

FIG. 1



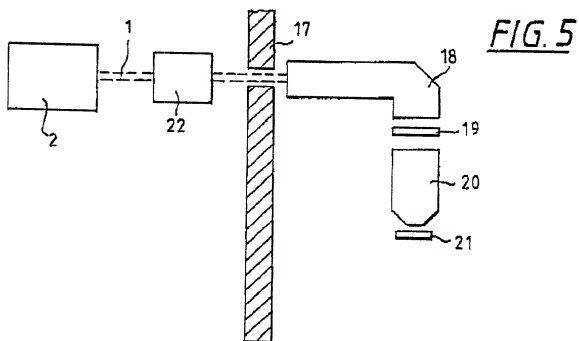
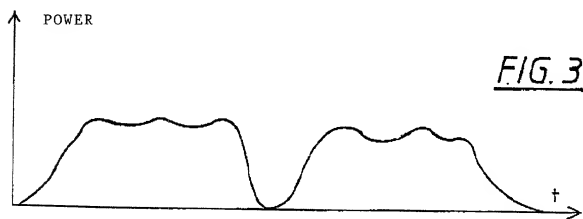
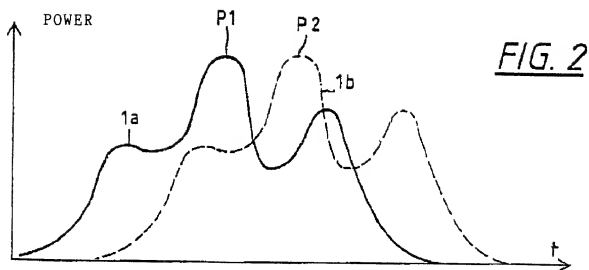
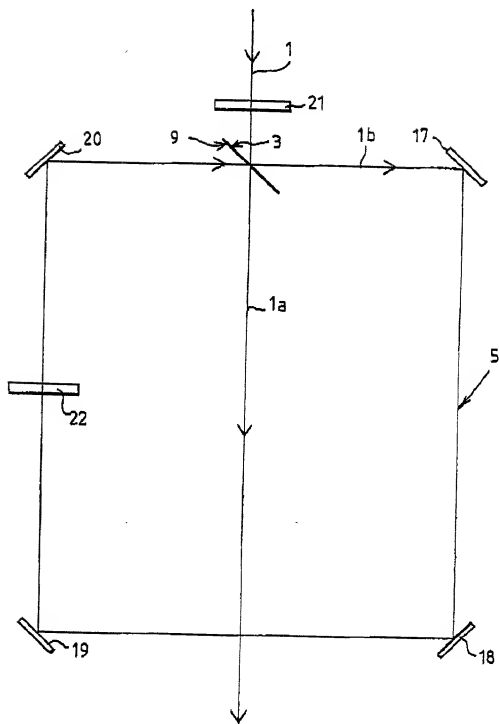


FIG. 4



20 2205 444

DECLARATION AND POWER OF ATTORNEY

As a below named inventor, I hereby declare:

That my residence, post office address and citizenship are as stated below next to my name.

That I verily believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural inventors are named below) of the subject matter which is claimed and for which a patent is sought on the invention entitled: Device for reducing the peak power of a
the specification of which (check one) pulsed laser light source

☒ is attached hereto.

☐ was filed on _____ as Application, Serial No. _____ and was amended on _____
(if applicable).

That I have reviewed and understand the contents of the above-identified specification, including the claims, as amended by any amendment referred to above.

That I acknowledge the duty to disclose information known to be material to patentability of this application in accordance with Title 37, Code of Federal Regulations § 1.56(a).

That I hereby claim foreign priority benefits under Title 35, United States Code, § 119 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate on this invention having a filing date before that of the application on which priority is claimed:

Prior Foreign Application(s)			Priority Claimed	
			<input checked="" type="checkbox"/> Yes	<input type="checkbox"/> No
<u>199 31 751.8</u>	<u>Germany</u>	<u>08.07.1999</u>		
(Number)	(Country)	(Day/Month/Year Filed)		
_____	_____	_____	<input type="checkbox"/> Yes	<input type="checkbox"/> No
(Number)	(Country)	(Day/Month/Year Filed)		

That I hereby claim the benefit under Title 35, United States Code, § 120 of any United States application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code, § 112, I acknowledge the duty to disclose material information as defined in Title 37, Code of Federal Regulations, § 1.56(a) which occurred between the filing date of the prior application and the national or PCT international filing date of this application:

United States Application(s)

<u>(Application Serial No.)</u>	<u>(Filing Date)</u>	<u>(Status)-(Patented, pending, abandoned)</u>
_____	_____	_____
<u>(Application Serial No.)</u>	<u>(Filing Date)</u>	<u>(Status)-(Patented, pending, abandoned)</u>
_____	_____	_____

That all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

I hereby appoint the following attorneys, with full power of substitution and revocation, to prosecute this application and to transact all business in the United States Patent and Trademark Office connected therewith and request that all correspondence and telephone calls in respect to this application be directed to: WELSH & KATZ, LTD., 120 South Riverside Plaza, 22nd Floor, Chicago, Illinois 60606-3913, Telephone No.: (312) 655-1500:

Attorney

Registration No.

Donald L. Welsh	16,665
A. Sidney Katz	24,003
Richard L. Wood	22,839
Jerold B. Schnayer	28,903
Eric C. Cohen	27,429
Joseph R. Marcus	25,060
Gerald S. Schur	22,053
Gerald T. Shekleton	27,466
James A. Scheer	29,434
Daniel R. Cherry	29,054
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Thomas W. Tolpin	27,600

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Full name of sole or one
joint inventor:

Schuster, Karl-Heinz

Inventor's signature:

Schuster, Karl-Heinz

Date:

18 - May - 2000

Residence and Post Office Address:

Rechbergstrasse 24

D-89551 Königsbrunn

Germany

Citizenship:

German

SECRET PLUS

Full name of additional joint
inventor, if any:

Bauer, Harry, Dr.

Inventor's signature:

Harry Bauer

Date:

25 - May - 2000

Residence and Post Office Address:

Wittelsbacherstrasse 2

D-73432 Aalen

Germany

Citizenship:

German

Full name of additional joint
inventor, if any:

EVA, Eric

Inventor's signature:

Eric Eva

Date:

26 - May - 2000

Residence and Post Office Address:

Waldstrasse 43

D-73432 Aalen

Germany

Citizenship:

German

Address for Correspondence:

WELSH & KATZ, LTD.
120 South Riverside Plaza
22nd Floor
Chicago, Illinois 60606-3913